

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	263	("registration marker")	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 15:49
L2	159	L1 and @ad<"20030820"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 15:49
L3	27	L2 and (forming creating placing depositing) near5 marker	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 15:51
L4	0	L3 and (sem "scanning electron microscope" stm "scanning tunnelling microscope" "optical microscope")	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 15:52
S31	126542	(sem "scanning electron microscope" stm "scanning tunnelling microscope" "optical microscope")	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:22
S32	6591	S31 and ((fet "field effect transistor") (cmos "complementary metal oxide semiconductor") (mosfet "metal oxide semiconductor field effect transistor"))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:24
S33	506	S32 and ("registration marker" marker)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:24
S36	49	S33 and ("registration marker" "trademark" "brand name")	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:27
S37	8	S36 and @ad<"20030820"	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/01/12 14:28

1/12/2009 3:52:59 PM

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